

Article **A Miniaturized Nickel Oxide Thermistor via Aerosol Jet Technology**

Chia Wang *, Guan-Yi Hong, Kuan-Ming Li and Hong-Tsu Young

Department of Mechanical Engineering, National Taiwan University, Taipei 10617, Taiwan; D04522013@ntu.edu.tw (G.-Y.H.); kmli@ntu.edu.tw (K.-M.L.); hyoung@ntu.edu.tw (H.-T.Y.)

***** Correspondence: D00522025@ntu.edu.tw; Tel.: +886-2-3366-4486

Received: 20 October 2017; Accepted: 9 November 2017; Published: 12 November 2017

Abstract: In this study, a miniaturized thermistor sensor was produced using the Aerosol Jet printing process for temperature sensing applications. A nickel oxide nanoparticle ink with a large temperature coefficient of resistance was fabricated. The thermistor was printed with a circular NiO thin film in between the two parallel silver conductive tracks on a cutting tool insert. The printed thermistor, which has an adjustable dimension with a submillimeter scale, operates over a range of 30–250 ◦C sensitively (B value of ~4310 K) without hysteretic effects. Moreover, the thermistor may be printed on a 3D surface through the Aerosol Jet printing process, which has increased capability for wide temperature-sensing applications.

Keywords: printed thermistor; Aerosol Jet; nickel oxide; temperature sensing; printing technology

1. Introduction

Temperature sensors are useful for sensing measurements in many dynamic applications, such as IC chips [\[1\]](#page-9-0) and manufacturing processing [\[2\]](#page-9-1). Compared to commercial temperature sensors, printed sensors are more advantageous because they fit the surface topography of measurement situations, demand less space for installation, and may use a wider range of substrates. Using printing technologies allows for even more sensing applications, enabling sensors to be printed on flexible polyimide foil, injection molded devices, and PCB [\[3\]](#page-9-2). In addition, printed technology is easier to make temperature sensing arrays and is capable of measuring the temperature distribution of a system rather than its average temperature. Turning process is a machining process that is useful in many areas. Turning inserts are the cutting tools that turning processes use to remove material from workpieces [\[4\]](#page-9-3). Cutting temperature has been recognized as a major factor that directly affects tool life [\[5\]](#page-9-4).

In the literature, some available methods have been discussed to showcase the possibilities of printed sensors. An inkjet-printed temperature sensor was made using commercial silver nanoparticle inks on paper as Ag resistance temperature detectors (RTDs) with dimensions of 16 mm \times 16 mm [\[6\]](#page-9-5), and it sensed temperatures between −20 and 60 ◦C with a temperature coefficient of resistance of 0.11%/K. An inkjet-printed nickel oxide thermistor array on a flexible substrate operated from room temperature to 200 °C with high sensitivity (B value of ~4300 K) [\[7\]](#page-9-6). Inkjet-printed square graphene thin films with dimensions of 8 mm \times 8 mm on polyimide substrates were used for temperature sensing applications, and the sensing temperatures ranged from 25 to 175 °C with moderate sensitivity (B value of 1860 K) [\[8\]](#page-9-7).

Aerosol Jet technology, a direct writing process, can deposit fine metal lines under 20 μ m [\[9\]](#page-9-8), utilizes nanoparticle inks in the range of 1–2500 cP, and can print polymers and adhesives. Conductor traces may be printed using gold, silver, or other nanoparticle inks [\[10\]](#page-9-9), and uniform and continuous thin film patterns may be formed by depositing precise amounts of inks in specific areas at room temperature and atmospheric pressure [\[11\]](#page-9-10).

In Figure [1,](#page-1-0) the research flowchart shows how the printed thermistors were fabricated and In Figure 1, the research flowchart shows how the printed thermistors were fabricated and confirmed through performance, and then used in real manufacturing and turning processes. In this confirmed through performance, and then used in real manufacturing and turning processes. In this study, the Aerosol Jet printing process was developed to fabricate miniaturized thermistors with high temperature sensitivity that can be printed directly on tiny cutting tools that are types of turning temperature sensitivity that can be printed directly on tiny cutting tools that are types of turning inserts. Nickel oxide is used as the temperature sensing material for printed thermistors because of its large temperature coefficient of resistance (TCR) and substantial chemical stability [\[7,](#page-9-6)[12–](#page-9-11)[16\]](#page-9-12).

Figure 1. The research flowchart. **Figure 1.** The research flowchart.

2. Experimental Setup 2. Experimental Setup

In order to print the thermistors on turning inserts, the insulation layer $(A_1_2O_3)$ is necessary. The curing temperature of NiO must be 200 $^{\circ}$ C for an hour to remove the ink solvents for NiO nanoparticle deposition [\[7\]](#page-9-6).

The substrates used were cutting inserts for printed electronics (Figure [2\)](#page-1-1), three different types of inserts that were chosen from KORLOY (Table 1) [an](#page-2-0)d have different 3D surfaces. In order to avoid the printed thermistors short-circuiting, all inserts were coated with an Al₂O₃ layer by physical vapor deposition (PVD) for insulation, and the thermistors were then printed on the Al₂O₃ layer (Figure 3). To furt[he](#page-2-1)r investigate the microstructure, the NiO thin film was examined by scanning electron microscopy (SEM). The dimension of each sensing element is about 0.1 mm (diameter), which to produce through Aerosol Jet printing technology. is easy to produce through Aerosol Jet printing technology. to produce through Aerosol Jet printing technology. element methodology (SEM). The dimension of each sensing element is about 0.1 mm (diameter),

Figure 2. The dimensions of the turning inserts used in this study [\[4\]](#page-9-3).

Figure 3. (a) The Al_2O_3 layer was coated on inserts for insulation; (b) the NiO thin film was examined by SEM. by SEM.

 \mathcal{S} ilver nanoparticle ink (NAGASE) was Aerosol Jet printed with a commercial printed with a commercial with a commercial printed with a commercial printed with a commercial printed with a commercial printed with a co Silver nanoparticle ink (NAGASE, Osaka, Japan) was Aerosol Jet printed with a commercial
Contract in 1988, The test pattern in the test pattern in the test pattern in the test pattern in the test pat commutation operator by soo primer (optimer, *i*nduquelque, *ivin, our)*. The ust patient included 80 µm wide lines for both dimensional and electrical characterization. In this study, the silver conducting lines were deposited at 180 °C for 0.5 h, and NiO thin films were then deposited on them. Finally, the deposited silver conducting lines with NiO thin films were thermally calcined at \sim continuous Optomec AJ-300 printer (Optomec, Albuquerque, NM, USA). The test pattern included 200 \degree C in a furnace for an hour [\[7\]](#page-9-6) to remove solvents.

2.1. NiO Nanoparticle Ink Preparation 2.1. NiO Nanoparticle Ink Preparation

The fabricated method of NiO nanoparticle inks (Table 2) followed the literature [7]. A pH range The fabricated method of NiO nanoparticle inks (Table [2\)](#page-2-2) followed the literature [\[7\]](#page-9-6). A pH range between 2 and 8 is suggested [7,17] for suspension stability and chemical issues, so the pH value of between 2 and 8 is suggested [\[7,](#page-9-6)[17\]](#page-9-13) for suspension stability and chemical issues, so the pH value of NiO inks was controlled within a range of 3–5 in this study. NiO inks was controlled within a range of 3–5 in this study.

Material	Weight (g)
Propylene Glycol Methyl Ether	
Dejonized water	
Nickel oxide powder	0.5

Table 2. The ingredients of NiO nanoparticle inks [7]. **Table 2.** The ingredients of NiO nanoparticle inks [\[7\]](#page-9-6).

2.2. Aerosol Jet Printing Technology 2.2. Aerosol Jet Printing Technology

Aerosol Jet technology was used to print Ag ink and NiO ink in this study. These liquid inks Aerosol Jet technology was used to print Ag ink and NiO ink in this study. These liquid inks with dispersed nanoparticles were aerosolized using an ultrasonic atomizer. The diameter of the aerosolized droplets is $1-5 \mu m$. These droplets flow to the print head, where they are surrounded by another gas, called the sheath gas, which aids collimating. N₂ is used for both the carrier and sheath flows in this study. Finally, the focused aerosol flow, which is essentially a multi-phase stream of solid nanoparticles and ink solvents in a gas, is passed through a nozzle $(100-300 \mu m)$ in diameter) and deposited at an ejection speed of 100 mm/s on the target substrate (Figure [4\)](#page-3-0).

Figure 4. A schematic diagram of Aerosol Jet printing process. **Figure 4.** A schematic diagram of Aerosol Jet printing process. **Figure 4.** A schematic diagram of Aerosol Jet printing process.

2.3. Experiments with Printed Sensor Calibration 2.3. Experiments with Printed Sensor Calibration 2.3. Experiments with Printed Sensor Calibration

In this study, the resistivity versus the temperature characteristics were measured over a temperature range of $90-250$ °C for at least three heating/cooling cycles. The printed thermistor of the B constant was calculated from the resistance versus the temperature characteristics using the Arrhenius Equation (1): Arrhenius Equation (1): erature range of 70 200 °C for at reast ance nearing, cooling cycles. The prime a therm

$$
B_{90/250} = \frac{\ln \frac{R_{90}}{R_{250}}}{\left(\frac{1}{T_{90}}\right) - \left(\frac{1}{T_{250}}\right)}
$$
(1)

where R_{90} and R_{250} are the resistances measured at 90 °C (T₉₀) and 250 °C (T₂₅₀), respectively.

2.3.1. Temperature Experiments via Heat Plate

The responses of the printed thermistors to temperature changes were evaluated through a heat 250 °C and then cooled down to 90 °C over the course of two cycles. The printed sensors were put on $\frac{1}{2}$ plant (Figure 5). The electrical resistance $\frac{1}{2}$ results from the sulted from the heat plate rose $\frac{1}{2}$ results from the heat plate rose $\frac{1}{2}$ results from the heat plate rose $\frac{1}{2}$ results from a heat plate first, and the hot plate, using a TPS-600S power supply, then elevated the temperature f_{max} 27 °C \overline{a} and the hot plate first, and the hot plate, using a TPS-600S power supply, then electron elements the temperature the temperature supply, then electron electron electron electron electron electron electron electr plate experiment (Fig[ur](#page-3-1)e 5). The electrical resistance variation that resulted from the heat plate rose to from 27° C.

Figure 5. The experimental setup of the heating test. **Figure 5.** The experimental setup of the heating test.

the printed thermistor were set to measure the temperature of the inserts in the same heating process In order to confirm the capability of the printed the printed the printed theorem is a commercial the commercial theorem is a commercial theorem in the commercial theorem is a commercial theorem in the commercial theorem In order to confirm the capability of the printed thermistor, the commercial thermocouple and (Table [3\)](#page-3-2).

Table 3. The measured equipment for two different temperature-sensing sources. **Equipment Model Sensitivity Signal Source Source Type**

In order to confirm the capability of the printed the printed the printed theorem \mathcal{L}

2.3.2. Verified Temperature Experiments via Heat Plate

In order to test the performance of the printed thermistors, the heat plate was set to six different temperature levels, beginning at 90 °C and rising at intervals of 30 °C. The thermocouple was used to record the temperature and was compared with the printed thermistors in the same fashion, as previously described. *2.4. Turning Processes*

2.4. Turning Processes F_{max} the real turning processes were three different turning depth levels t_{max} in the tested in the theorem the the principal the printed the printed the printed theorem since $\frac{1}{n}$

Finally, the real turning processes were executed. There were three different turning depth levels that were tested in turning processes, and both the thermocouple and the printed thermistor were installed on the turning insert. The turning processes are shown in Table 4 and Figure [6.](#page-4-1)

Table 4. The experimental setup of the turning processes.						
Workpiece Material	Workpiece Size	Turning Insert	Process Feed	Process Depth	Process Speed	
Aluminum	60 mm (D) \times 750 mm (L)	TNGG-SC	0.105 mm/rev	$1/1.5/2$ mm	1800 rpm	

Printed thermistor Turning Insert Workpiece

Figure 6. The turning processes were used to confirm the performance of the printed thermistor on **Figure 6.** The turning processes were used to confirm the performance of the printed thermistor on the turning inserts.

3. Results and Discussion 3. Results and Discussion

The thermocouple was installed in close proximity to the printed thermistor (Fig[ur](#page-5-0)e 7), and it was found that both the thermocouple and the printed thermistor had the same approximate temperature during the heating p[roc](#page-5-1)ess (Figure 8). Both the printed thermistors and thermocouple reacted in less than a second to a temperature change. This proves that the printed thermistor has a high sensitivity and is able to measure temperature changes with great precision.

Figure 7. The experimental setup of the heat plate tests. **Figure 7.** The experimental setup of the heat plate tests.

thermocouple was and the NiO-based printed the turning process by the Figure 8. The two different temperature sensors in the heating process by heat plate: (a) the T-type thermocouple, and (**b**) the NiO-based printed thermistor on the turning insert. thermocouple, and (**b**) the NiO-based printed thermistor on the turning insert.

3.1. The Results of the Temperature Experiments 3.1. The Results of the Temperature Experiments 3.1. The Results of the Temperature Experiments

The thermistors on three of the turning inserts (Figure 9) possessed great temperature sensitivity. The inermistors on three of the turning inserts (rigure θ) possessed great temperature sensitivity. rhose printed thermistors were placed on the not plate, and the transient promes of electrical resistance with temperature variation were recorded (Figure 10). This showed that the B values of the thermistors $\overline{}$ went up to 4510 K (Table 5). This B value is close to that or conventional metal oxide negative temperature coefficient (ivity) materials, which are typically in the range or 2000 to 5000 K [15], and the heating and cooling cycles virtually overlapped, indicating The thermistors on three of the turning inserts (Figure 9) possessed great temperature sensitivity. The thermistors on three of the turning inserts (Figure [9\)](#page-6-0) possessed great temperature sensitivity. Those printed thermistors were placed on the hot plate, and the transient profiles of electrical Those printed thermistors were placed on the hot plate, and the transient profiles of electrical resistance with temperature variation were recorded (Figure [10\)](#page-6-1). This showed that the B values of the thermistors went up to 4310 K (Table [5\)](#page-5-2). This B value is close to that of conventional metal oxide negative negative temperature coefficient (NTC) materials, which are typically in the range of 2000 to 5000 K temperature coefficient (NTC) materials, which are typically in the range of 2000 to 5000 K [\[13\]](#page-9-14), and [13], and the heating and cooling cycles virtually overlapped, indicating that there was almost no the heating and cooling cycles virtually overlapped, indicating that there was almost no electrical electrical resistance hysteresis regarding temperature variation. resistance hysteresis regarding temperature variation.

Table 5. The corresponding B values for the printed thermistors. **Table 5.** The corresponding B values for the printed thermistors. **Table 5.** The corresponding B values for the printed thermistors.

Turning Insert Type	B Values (90 °C–250 °C)
(a) $TNMG-VP3$	3671 K
(b) TNMG-HA	2829 K
(c) TNGG-SC	4310 K

Figure 9. Three printed thermistors on different turning inserts [\[7\]](#page-9-6).

Figure 10. The printed thermistors on three different 3D surface inserts have stable curves in the heating process: (a) TNMG-VP3, (b) TNMG-HA, and (c) TNGG-SC.

According to the resistivity variation of printed thermistors as a function of temperature, the relation was as shown in the equations below: relation was as shown in the equations below: relation was as shown in the equations below:

$$
T = 458.69R^{-0.292}
$$
 (2)

$$
T = 972.48R^{-0.462} \tag{3}
$$

$$
T = 332.76R^{-0.276} \tag{4}
$$

where *T* is the temperature (°C), and *R* is the resistivity (Million-ohm). Equation (2) is the relation of TNMG-VP3, Equation (3) is the relation of TNMG-HA, and Equation (4) is the relation of TNGG-SC.

3.2. The Results of Verified Temperature Experiments

Finally, using Equations (2)–(4), three types of printed thermistors can be compared to commercial thermocouples in verified temperature tests.

In the verified temperature tests, the temperature was measured by the commercial thermocouple, and the resulting resistance data of the printed thermistors was translated into temperature results by end the resulting resistance data or the printed thermistoric was translated into temperature results by Equations (2)–(4). The printed thermistor showed a similar equilibrium temperature scale as that of the thermocouple (Figure [11\)](#page-7-0). t^2 –(4). The printed thermistor showed a similar equilibrium temperature seare as

Figure 11. Verified temperature test results of three types of turning inserts. (a) TNMG-VP3, TNMG-HA, and (**c**) TNGG-SC. (**b**) TNMG-HA, and (**c**) TNGG-SC.

Table 6 shows the temperature error percentage of the printed thermistor with thermocouple results. TNMG-HA has the largest average error percentage and TNGG-SC has the smallest average error percentage proportional to the complexity of the geometric shape.

States	(a) TNMG-VP3	(b) TNMG-HA	(c) TNGG-SC
1 (90 °C)	-0.1%	-5.2%	1%
2 (120 °C)	-4.2%	9.6%	-2.8%
3 (150 °C)	$-4.3%$	10.7%	-2.4%
4 (180 °C)	-3.1%	1.8%	$-1.3%$
5 (210 °C)	$-1.3%$	-2.7%	-1%
6 (240 °C)	1.5%	-0.8%	-1.2%

Table 6. The temperature error percentage of each printed thermistor. **Table 6.** The temperature error percentage of each printed thermistor.

3.3. Turning Process Results 3.3. Turning Process Results

In the turning process results, the temperature that was measured by the thermocouple has an In the turning process results, the temperature that was measured by the thermocouple has an approximate variety and sensitivity according to the resistance that was measured by the printed approximate variety and sensitivity according to the resistance that was measured by the printed thermistors (Figure [12\).](#page-8-1) Using Equation (4), the resistance can be translated into temperature. The largest temperature error is under 3.2% during Turning Process 1. The standard deviation is 0.85%, and the average error is 0.3% during all turning processes. The two temperature curves are very close, illustrating the positive correlation between the thermocouple and the printed thermistors. The performance of the printed thermistors was confirmed in the turning processes. performance of the printed thermistors was confirmed in the turning processes.

Figure 12. (**a**) The resistance of the printed thermistor and the measured temperature of the **Figure 12.** (**a**) The resistance of the printed thermistor and the measured temperature of the thermocouple. (b) The temperature estimated from the resistance of the printed thermistors; the two temperature curves are very close.

4. Conclusions 4. Conclusions

The NiO-based 3D printed thermistors created via the Aerosol Jet printing process on turning The NiO-based 3D printed thermistors created via the Aerosol Jet printing process on turning inserts for temperature-sensing applications were shown to be highly capable. The printed inserts for temperature-sensing applications were shown to be highly capable. The printed thermistors on the three 3D inserts have high temperature sensitivity (B values of ~4310 K) without hysteretic effects, and the response time of the printed thermistors was almost as fast as that of the thermocouples. The Aerosol Jet technology has the flexibility to print circuit layouts on 3D structures, the thermistors may be allocated to different positions easily with a variety of circuit layouts, and the dimensions of the sensing element may be easily reduced below 0.1 mm. In summary, this study shows the high potential applicability of the sensors in the printed electronics area and provides an answer to the miniaturized sensing devices problem that is not limited by traditional coating/etching processes.

performed the experiments; C.W. analyzed the data; C.W. and G.-Y.H. contributed reagents/materials/analysis
in a G.W. p_{cov} contributed the experiments; p_{cov} **Author Contributions:** C.W., K.-M.L. and H.-T.Y. conceived and designed the experiments; C.W. and G.-Y.H. tools; C.W. wrote the paper.

Conflicts of Interest: The authors declare no conflict of interest.

References

- 1. Liu, H.X.; Sun, W.Q.; Xiang, A.; Shi, T.W.; Chen, Q.; Xu, S.Y. Towards on-chip time-resolved thermal mapping with micro-/nanosensor arrays. *Nanoscale Res. Lett.* **2012**, *7*, 484. [\[CrossRef\]](http://dx.doi.org/10.1186/1556-276X-7-484) [\[PubMed\]](http://www.ncbi.nlm.nih.gov/pubmed/22931306)
- 2. Li, K.M.; Liang, S.Y. Modeling of Cutting Temperature in Near Dry Machining. *J. Manuf. Sci. Eng.* **2005**, *128*, 416–424. [\[CrossRef\]](http://dx.doi.org/10.1115/1.2162907)
- 3. Cost Effective Additive Material Deposition. Available online: <http://www.hahn-schickard.de> (accessed on 4 May 2015).
- 4. Korloy Cutting Tools. Available online: <https://www.cutwel.co.uk/Korloy-Cutting-Tools> (accessed on 1 April 2014).
- 5. Teti, R.; Jemielniak, K.; O'Donnell, G.; Dornfeld, D. Advanced monitoring of machining operations. *CIRP Ann.-Manuf. Technol.* **2010**, *59*, 717–739. [\[CrossRef\]](http://dx.doi.org/10.1016/j.cirp.2010.05.010)
- 6. Courbat, J.; Kim, Y.B.; Briand, D.; de Rooij, N.F. Inkjet printing on paper for the realization of humidity and temperature sensors. In Proceedings of the 16th International Conference on Solid-State Sensors, Actuators and Microsystems, Beijing, China, 5–9 June 2011. [\[CrossRef\]](http://dx.doi.org/10.1109/TRANSDUCERS.2011.5969506)
- 7. Huang, C.C.; Kao, Z.K.; Liao, Y.C. Flexible Miniaturized Nickel Oxide Thermistor Arrays via Inkjet Printing Technology. *ACS Appl. Mater. Interfaces* **2013**, *5*, 12954–12959. [\[CrossRef\]](http://dx.doi.org/10.1021/am404872j) [\[PubMed\]](http://www.ncbi.nlm.nih.gov/pubmed/24298996)
- 8. Kong, D.; Le, L.T.; Li, Y.; Zunino, J.L.; Lee, W. Temperature-dependent electrical properties of graphene inkjet-printed on flexible materials. *Langmuir* **2012**, *28*, 13467–13472. [\[CrossRef\]](http://dx.doi.org/10.1021/la301775d) [\[PubMed\]](http://www.ncbi.nlm.nih.gov/pubmed/22924965)
- 9. Mette, A.; Richter, P.L.; Hörteis, M.; Glunz, S.W. Metal Aerosol Jet printing for solar cell metallization. *Prog. Photovolt. Res. Appl.* **2007**, *115*, 621–627. [\[CrossRef\]](http://dx.doi.org/10.1002/pip.759)
- 10. Direct Write Printing for Mil-Aero Electronic Applications. Available online: [https://www.optomec.com/](https://www.optomec.com/wp-content/uploads/2014/04/Optomec_Aerosol_Jet_Direct_Write_Printing_for_Mil_Aero_Electronic_Apps.pdf) [wp-content/uploads/2014/04/Optomec_Aerosol_Jet_Direct_Write_Printing_for_Mil_Aero_Electronic_](https://www.optomec.com/wp-content/uploads/2014/04/Optomec_Aerosol_Jet_Direct_Write_Printing_for_Mil_Aero_Electronic_Apps.pdf) [Apps.pdf](https://www.optomec.com/wp-content/uploads/2014/04/Optomec_Aerosol_Jet_Direct_Write_Printing_for_Mil_Aero_Electronic_Apps.pdf) (accessed on 1 April 2014).
- 11. Salary, R.; Lombardi, J.P.; Tootooni, M.S.; Donovan, R.; Rao, P.K.; Poliks, M.D. In situ sensor-based monitoring and computational fluid dynamics (CFD) modeling of Aerosol Jet printing (AJP) process. In Proceedings of the ASME 2016 11th International Manufacturing Science and Engineering Conference, Blacksburg, VA, USA, 27 June–1 July 2016. [\[CrossRef\]](http://dx.doi.org/10.1115/MSEC2016-8535)
- 12. Aleksica, O.S.; Nikolic, M.V.; Lukovic, M.D.; Nikolic, N.; Radojcic, B.M.; Radovanovic, M.; Djuric, Z.; Nikolic, P.M. Preparation and characterization of Cu and Zn modified nickel manganite NTC powders and thick film thermistors. *Mater. Sci. Eng. B* **2013**, *178*, 202–210. [\[CrossRef\]](http://dx.doi.org/10.1016/j.mseb.2012.11.003)
- 13. Kang, J.E.; Ryu, H.; Han, G.; Choi, J.J.; Yoon, W.H.; Hahn, B.D.; Kim, J.W.; Ahn, C.W.; Choi, J.H.; Park, D.S. LaNiO₃ conducting particle dispersed NiMn₂O₄ nanocomposite NTC thermistor thick films by aerosol deposition. *J. Alloys Compd.* **2012**, *534*, 70–73. [\[CrossRef\]](http://dx.doi.org/10.1016/j.jallcom.2012.04.038)
- 14. Ko, S.W.; Schulze, H.M.; Saint John, D.B.; Podraza, N.J.; Dickey, E.C.; Trolier-McKinstry, S.S. Low Temperature Crystallization of Metastable Nickel Manganite Spinel Thin Films. *J. Am. Ceram. Soc.* **2012**, *95*, 2562–2567. [\[CrossRef\]](http://dx.doi.org/10.1111/j.1551-2916.2012.05201.x)
- 15. Ryu, J.; Kim, K.Y.; Choi, J.J.; Hahn, B.D.; Yoon, W.H.; Lee, B.K.; Park, D.S.; Park, C. Highly Dense and Nanograined NiMn₂O₄ Negative Temperature Coefficient Thermistor Thick Films Fabricated by Aerosol-Deposition. *J. Am. Ceram. Soc.* **2009**, *92*, 3084–3087. [\[CrossRef\]](http://dx.doi.org/10.1111/j.1551-2916.2009.03300.x)
- 16. Schulze, H.; Li, J.; Dickey, E.C.; Trolier-Mckinstry, S. Synthesis, Phase Characterization, and Properties of Chemical Solution-Deposited Nickel Manganite Thermistor Thin Films. *J. Am. Ceram. Soc.* **2009**, *92*, 738–744. [\[CrossRef\]](http://dx.doi.org/10.1111/j.1551-2916.2009.02944.x)
- 17. Hernández, N.; Moreno, R.; Sánchez-Herencia, A.J.; Fierro, J.L.J. Surface Behavior of Nickel Powders in Aqueous Suspensions. *J. Phys. Chem. B* **2005**, *109*, 4470–4474. [\[CrossRef\]](http://dx.doi.org/10.1021/jp0448954) [\[PubMed\]](http://www.ncbi.nlm.nih.gov/pubmed/16851519)

© 2017 by the authors. Licensee MDPI, Basel, Switzerland. This article is an open access article distributed under the terms and conditions of the Creative Commons Attribution (CC BY) license [\(http://creativecommons.org/licenses/by/4.0/\)](http://creativecommons.org/licenses/by/4.0/.).